



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Naoyuki KOBAYASHI et al.

Group Art Unit: 2882

Application No.: 10/588,297

Examiner: M. ASFAW

Filed: August 2, 2006

Docket No.: 128977

For: EXPOSURE APPARATUS, EXPOSURE METHOD, AND METHOD FOR
PRODUCING DEVICE

AMENDMENT WITH REQUEST FOR CONTINUED EXAMINATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the July 22, 2011 Office Action, the shortened period for reply being extended by the attached Petition for Extension of Time, and upon entry of the attached Request for Continued Examination, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.